



Attorney Docket # 5328-15

*IFW*  
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Shinobu ISOBE et al.

Serial No.: 10/681,993

Filed: October 8, 2003

For: Semiconductor Device, and Design Method,  
Inspection Method, and Design Program Therefor

Examiner: KIK, Phallaka  
Group Art: 2825

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

March 29, 2006  
(Date of Deposit)

Thomas Langer

Name of applicant, assignee or Registered Representative

*Thomas Langer*  
Signature

March 29, 2006  
Date of Signature

**Mail Stop Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

SIR:

In response to the Office Action dated December 29, 2005, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Amendments to the Drawings** begin on page 5 of this paper and include attached replacement sheets.

**Remarks** begin on page 6 of this paper.